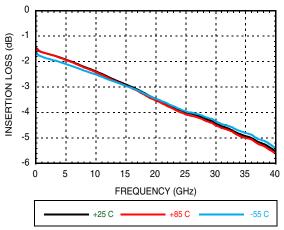


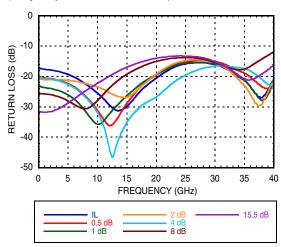
0.5 dB LSB GaAs MMIC 5-BIT DIGITAL ATTENUATOR, 0.1 - 30 GHz

Insertion Loss vs. Temperature

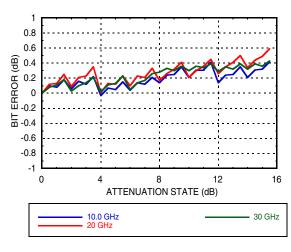


Input Return Loss

(Only Major States are Shown)

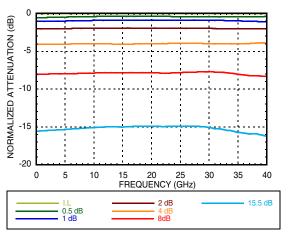


Bit Error vs. Attenuation State



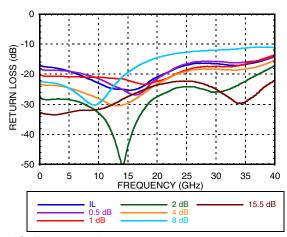
Normalized Attenuation

(Only Major States are Shown)



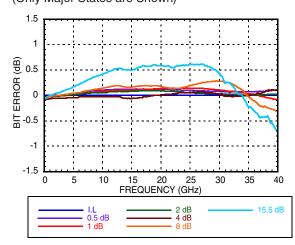
Output Return Loss

(Only Major States are Shown)



Bit Error vs. Frequency

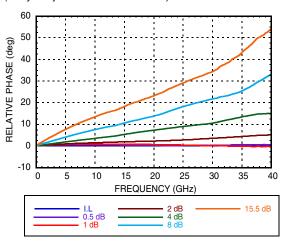
(Only Major States are Shown)



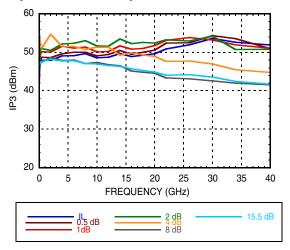
0.5 dB LSB GaAs MMIC 5-BIT DIGITAL ATTENUATOR, 0.1 - 30 GHz

Relative Phase vs. Frequency

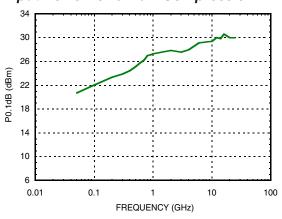
(Only Major States are Shown)



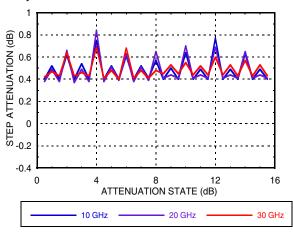
Input IP3 Over Major Attenuation States



Input Power for 0.1 dB Compression

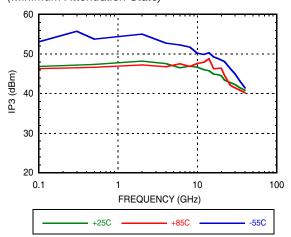


Step Attenuation vs. Attenuation State



Input IP3 vs. Temperature

(Minimum Attenuation State)



Truth Table

	Control Voltage Input				Attenuation
P4 8 dB	P3 4 dB	P2 2 dB	P1 1 dB	P0 0.5 dB	State RF1 - RF2
High	High	High	High	High	Reference I.L.
High	High	High	High	Low	0.5 dB
High	High	High	Low	High	1 dB
High	High	Low	High	High	2 dB
High	Low	High	High	High	4 dB
Low	High	High	High	High	8 dB
Low	Low	Low	Low	Low	15.5 dB

Any Combination of the above states will provide an attenuation approximately equal to the sum of the bits selected.



0.5 dB LSB GaAs MMIC 5-BIT DIGITAL ATTENUATOR, 0.1 - 30 GHz

Absolute Maximum Ratings

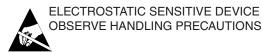
Absolute maximum natings				
RF Input Power (0.5 to 30 GHz)	+27 dBm			
Control Voltage (P0 to P4)	Vdd + 0.5V			
Vdd	+7 Vdc			
Vss	-7 Vdc			
Channel Temperature	150 °C			
Continuous Pdiss (T=85°C) (derate 6.97 mW/°C above 85°C)	0.453 W			
Thermal Resistance (channel to die bottom)	143.5 °C/W			
Storage Temperature	-65 to + 150 °C			
Operating Temperature	-55 to +85 °C			
ESD Sensitivity (HBM)	Class 1A			

Bias Voltages & Currents

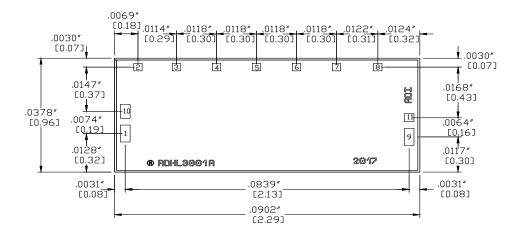
Vdd	+5V @ 5 mA (Typ)
Vss	-5V @ 6 mA (Typ)

Control Voltage

State	Bias Condition
Low	0 to 0.8V @ 1 μA (Typ)
High	2 to 5V @ 1 μA (Typ)



Outline Drawing



PAD	DESCRIPTION	PAD SIZE
1	RF1	0.0056"[0.14] X 0.0029"[0.07]
2	VSS	0.0025"[0.06] X 0.0025"[0.06]
3,4,5,6,7	PO,P1,P2,P3,P4	0.0025"[0.06] X 0.0025"[0.06]
8	VDD	0.0025"[0.06] X 0.0025"[0.06]
9	RF2	0.0056"[0.14] X 0.0029"[0.07]
10	GND	0.0046"[0.12] X 0.0029"[0.07]
11	GND	0.0029"[0.07] X 0.0029"[0.07]

- 1. ALL DIMENSIONS ARE IN INCHES [MILLIMETERS]
- 2. TYPICAL BOND PAD SPACING IS 0.0118"
 CENTER TO CENTER EXCEPT AS NOTED.
- 3. BACKSIDE METALIZATION: GOLD
- 4. BACKSIDE METAL IS GROUND
- 5. BOND PAD METALIZATION: GOLD

Die Packaging Information [1]

Standard	Alternate
WP-9 (Waffle Pack)	[2]

- [1] Refer to the "Packaging Information" section for die packaging dimensions.
- [2] For alternate packaging information contact Analog Devices Inc.

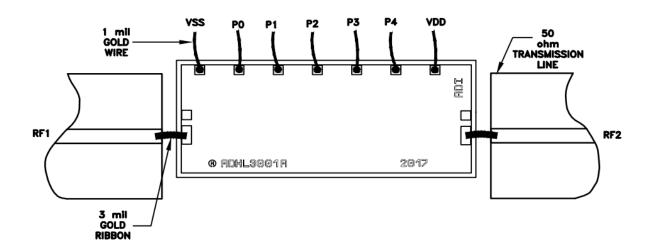


0.5 dB LSB GaAs MMIC 5-BIT DIGITAL ATTENUATOR, 0.1 - 30 GHz

Pad Descriptions

Pad Number	Function	Description	Interface Schematic
10,11	GND	Die bottom must be connected to RF ground.	⊖ GND =
1, 9	RF1, RF2	This pad is DC coupled and matched to 50 Ohm. Blocking capacitors are required if RF line potential is not equal to 0V.	
2	Vss	Negative Bias -5V	Vss 3pF ==
3 - 7	P0 - P4	See truth table and control voltage table.	P0-P4 0
8	Vdd	Positive Bias +5V	Vdd — 3pF — = =

Assembly Diagram





0.5 dB LSB GaAs MMIC 5-BIT DIGITAL ATTENUATOR, 0.1 - 30 GHz

Mounting & Bonding Techniques for Millimeterwave GaAs MMICs

The die should be attached directly to the ground plane eutectically or with conductive epoxy (see HMC general Handling, Mounting, Bonding Note).

50 Ohm Microstrip transmission lines on 0.127mm (5 mil) thick alumina thin film substrates are recommended for bringing RF to and from the chip (Figure 1). If 0.254mm (10 mil) thick alumina thin film substrates must be used, the die should be raised 0.150mm (6 mils) so that the surface of the die is coplanar with the surface of the substrate. One way to accomplish this is to attach the 0.102mm (4 mil) thick die to a 0.150mm (6 mil) thick molybdenum heat spreader (moly-tab) which is then attached to the ground plane (Figure 2).

Microstrip substrates should brought as close to the die as possible in order to minimize bond wire length. Typical die-to-substrate spacing is 0.076mm to 0.152 mm (3 to 6 mils).

Handling Precautions

Follow these precautions to avoid permanent damage.

Storage: All bare die are placed in either Waffle or Gel based ESD protective containers, and then sealed in an ESD protective bag for shipment. Once the sealed ESD protective bag has been opened, all die should be stored in a dry nitrogen environment.

Cleanliness: Handle the chips in a clean environment. DO NOT attempt to clean the chip using liquid cleaning systems.

Static Sensitivity: Follow ESD precautions to protect against ESD strikes.

Transients: Suppress instrument and bias supply transients while bias is applied. Use shielded signal and bias cables to minimize inductive pickup.

General Handling: Handle the chip along the edges with a vacuum collet

or with a sharp pair of bent tweezers. The surface of the chip has fragile air bridges and should not be touched with vacuum collet, tweezers, or fingers.

Mounting

The chip is back-metallized and can be die mounted with AuSn eutectic preforms or with electrically conductive epoxy. The mounting surface should be clean and flat.

Eutectic Die Attach: A 80/20 gold tin preform is recommended with a work surface temperature of 255 °C and a tool temperature of 265 °C. When hot 90/10 nitrogen/hydrogen gas is applied, tool tip temperature should be 290 °C. DO NOT expose the chip to a temperature greater than 320 °C for more than 20 seconds. No more than 3 seconds of scrubbing should be required for attachment.

Epoxy Die Attach: Apply a minimum amount of epoxy to the mounting surface so that a thin epoxy fillet is observed around the perimeter of the chip once it is placed into position. Cure epoxy per the manufacturer's schedule.

Wire Bonding

Ball or wedge bond with 0.025mm (1 mil) diameter pure gold wire. Thermosonic wirebonding with a nominal stage temperature of 150 °C and a ball bonding force of 40 to 50 grams or wedge bonding force of 18 to 22 grams is recommended. Use the minimum level of ultrasonic energy to achieve reliable wirebonds. Wirebonds should be started on the chip and terminated on the package or substrate. All bonds should be as short as possible <0.31mm (12 mils).

